

Title: POLISHING PADS USEFUL IN
CHEMICAL MECHANICAL POLISHING OF
SUBSTRATES IN THE PRESENCE OF A SLURRY
CONTAINING ABRASIVE PARTICLES
Inventor Name: Oscar K. Hsu et al.
Appl. No. Unassigned
Docket No. FREUN-118AX

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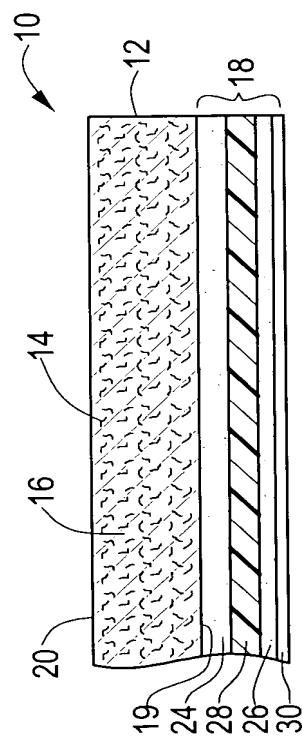


FIG. 1

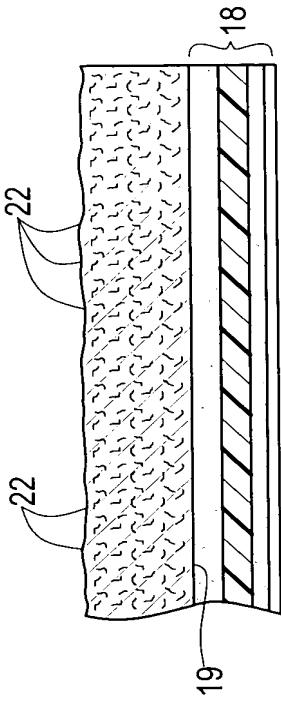


FIG. 3

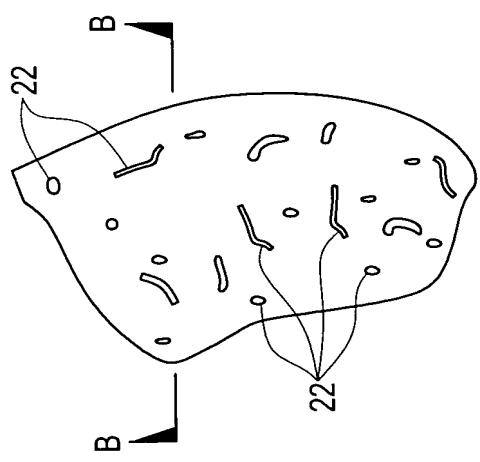


FIG. 2

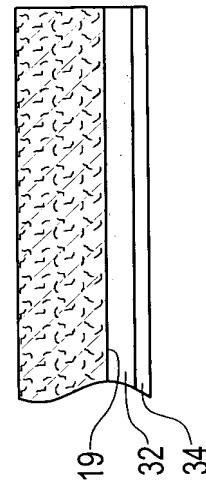


FIG. 4

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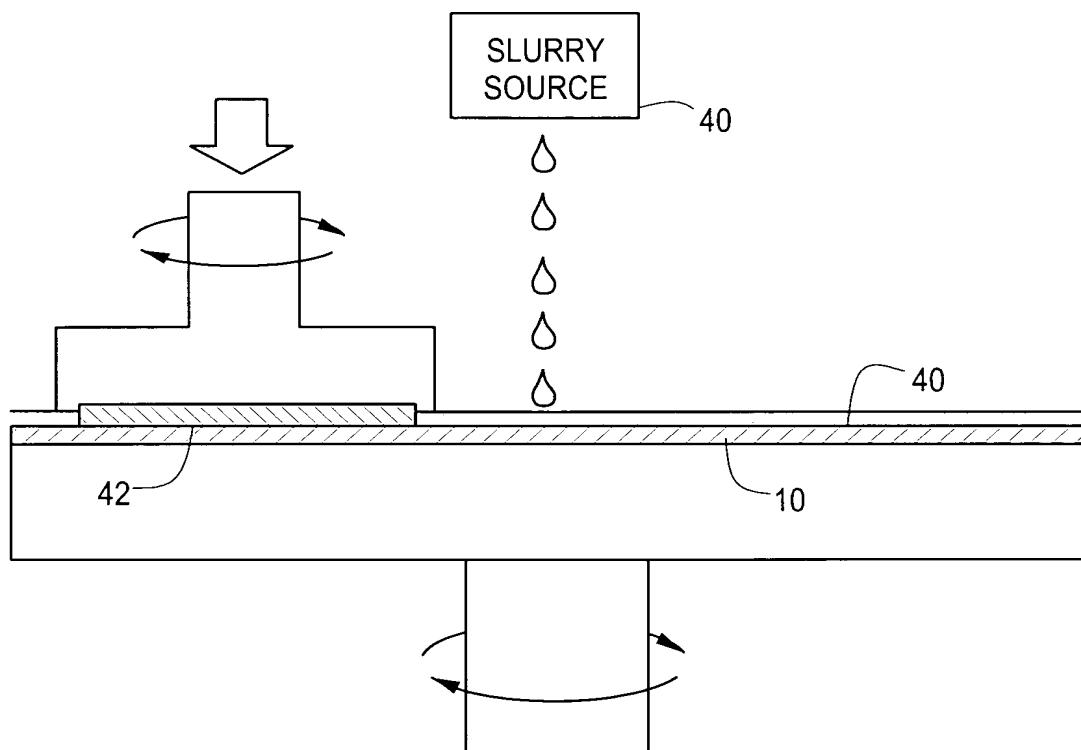


FIG. 5